

U.S. Department of Commerce, Patent and Trademark Office

Document No.

Serial No.

AMAT/2905.P1

09/505,580

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant

Reimer et al.

Filing Date

02/16/1000

Group

Unknown

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
PRB	AA	5,944,049	08/31/1999	BEYER ET AL.	137	487.5	July 15, 1997
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

RECEIVED
SEP - 1 2000
TC 1700 MAIL ROOM

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

Examiner

Date Considered

R. Buh

7-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2981.P1/ ECORE/CORE/MBE	Serial No. 09/505,580
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Reimer, et al.	Confirmation No. 5947
(Use several sheets if necessary)		Filing Date February 16, 2000	Group 2825
Examiner Unknown			

U.S. Patent Documents

Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
RRB	A1	6,080,679	06-27-2000	Suzuki	438	726	05-19-1998
	A2	5,904,952	05-18-1999	Lopata, et al.	427	8	08-01-1997
	A3	5,709,753	01-20-1998	Olson, et al.	118	719	10-27-1995
	A4	5,651,867	07-29-1997	Kokaku, et al.	204	298.25	10-02-1990
	A5	5,575,853	11-19-1996	Arami, et al.	118	708	06-29-1995
RRB	A6	5,174,827	12-29-1992	Misiano, et al.	118	719	04-03-1992
	A7						
	A8						
	A9						

RECEIVED

MAR 13 2002

TC 1700

Foreign Patent Documents

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
RRB	B1	JP 2-184333 w/ English Abstract	07-18-1990	Japan	B01J	3/02		X
	B2	JP 4-358531 w/ English Abstract	12-11-1992	Japan	B01J	3/02		X
	B3	JP 9-168732 w/ English Abstract	06-30-1997	Japan	B01J	3/02		X
	B4	JP 6-29367	02-04-1994	Japan	H01L	21/58		
	B5	JP 7-167053 w/ English Abstract	07-04-1995	Japan	F04B	37/16		
RRB	B6	JP 9-251981 w/ English Abstract	09-22-1997	Japan	H01L	21/2065		

TC 1700

MAR 12 2002

RECEIVED

OTHER ART

Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
RRB	C1	O'Hanlon, John F., "A User's Guide to Vacuum Technology," John Wiley & Sons, Inc., 2 nd Edition, 1989, Pages 349 - 352, 354.
RRB	C2	Beyer, et al., United States Patent Application, "An Apparatus and Method for Regulating a Pressure in a Chamber."

Examiner R. B. B. Date Considered 7-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2981.P1/E CORE/CORE/MBE	Serial No. 09/505,580
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)		Applicant Reimer, et al.	Confirmation No. 5947
Examiner Unknown		Filing Date February 16, 2000	Group 225

U.S. Patent Documents

Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date Appropriate
	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						

Foreign Patent Documents

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
RRB	B1	JP 8-74041	03-19-1996	Japan	C23C	14/24		X
	B2							
	B3							
	B4							
	B5							
	B6							
	B7							

OTHER ART

Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
	C3	

Examiner R. B. B. Date Considered 7-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.